

**Molecular Imprints, Inc.****RECEIVED
CENTRAL FAX CENTER****JUL 26 2005**Legal Department
P.O. Box 81536
Austin, Texas 78708-1536Telephone: (512) 339-7760
Facsimile: (512) 491-8918
mcarter@millitho.com**FACSIMILE TRANSMITTAL SHEET****TO:** Examiner CHRISTOPHER G. YOUNG
Group Art Unit 1756**FROM:** Michael D. Carter
Reg. No. 56,661**COMPANY:**
United States Patent and Trademark Office**DATE:**
July 26, 2005**FAX NUMBER:**
571-273-8300**TOTAL NO. OF PAGES INCLUDING COVER:**
6**RE:****INFORMATION DISCLOSURE STATEMENT**

U.S. Patent Application No. 10/735,110

Filing Date: December 12, 2003

Entitled: Magnification Correction Employing Out-Of-Plane Distortion of a Substrate

Our Ref. No.: P122-64V58

Please see attached:

IDS, including Transmittal (2 pgs)
Form PTO/SB/08 or 1449 (2 pgs),
1 Copy of Cited References (1 pg)

MDC:kep

The information contained in this facsimile message is intended only for the personal and confidential use of the designated recipient(s) named above. This message may be an attorney-client communication, and as such is privileged and confidential. If the reader of this message is not the intended recipient or an agent responsible for delivering it to the intended recipient, you are hereby notified that you have received this document in error and that any review, dissemination, distribution or copying of this message is strictly prohibited. If you have received this communication in error, please notify us immediately by telephone and return the original message to us by mail. Thank you.

RECEIVED
CENTRAL FAX CENTER

JUL 26 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Nimmakayala, Pawan Kumar
App. No.: 10/735,110 GPAU: 1756
Filing Date: 12/12/2003 Examiner: Christopher G. Young
Dkt. No.: P122-64V58 Conf. No.: 1928
For: Magnification Correction Employing Out-Of-Plane Distortion
of a Substrate

INFORMATION DISCLOSURE STATEMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure and pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98. The undersigned brings the patents, publications, applications or other information identified in the attached:

- ☒ Form(s) PTO/SB/08A and/or PTO/SB/08B or PTO/1449
☐ Other:

to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed:

before the mailing date of a first Office action on the merits or before the mailing date of a first Office action after the filing of a request for continued examination under § 1.114. Therefore, no fee is believed required.

Applicants do not believe that any additional fees are due, but if the Commissioner believes additional fees are due, the Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account Number 502650.

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as either First Class Mail or Express Mail, in an envelope addressed to the Commissioner for Patents.

Signed: Katrina Prati
Typed Name: Katrina Prati
Date: 7-26-05

Respectfully Submitted,



Michael D. Carter
Reg. No. 56,661
Registered Patent Agent
Legal Department
Molecular Imprints, Inc.
P.O. Box 81536
Austin, TX 78758-1536
(512) 339-7760
(512) 491-8918 (fax)

JUL 26 2005

PTO/SB/D8A (08-03)

Approved for use through 7/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449A/PTO				<div> <div>Complete if Known</div> <table border="1"> <tr> <td>APPLICATION NUMBER</td> <td>10/735,110</td> </tr> <tr> <td>FILING DATE</td> <td>12/12/2003</td> </tr> <tr> <td>FIRST NAMED INVENTOR</td> <td>Nimmakayala et al.</td> </tr> <tr> <td>Group Art Unit</td> <td>1756</td> </tr> <tr> <td>Examiner Name</td> <td>Christopher G. Young</td> </tr> <tr> <td>Attorney Docket Number</td> <td>P122-65V58</td> </tr> </table> </div>		APPLICATION NUMBER	10/735,110	FILING DATE	12/12/2003	FIRST NAMED INVENTOR	Nimmakayala et al.	Group Art Unit	1756	Examiner Name	Christopher G. Young	Attorney Docket Number	P122-65V58
APPLICATION NUMBER	10/735,110																
FILING DATE	12/12/2003																
FIRST NAMED INVENTOR	Nimmakayala et al.																
Group Art Unit	1756																
Examiner Name	Christopher G. Young																
Attorney Docket Number	P122-65V58																
<div> <div>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</div> <div>(use as many sheets as necessary)</div> </div>																	
Sheet	1	of	2														

[illegible]

Examiner Signature		Date Considered	
-----------------------	--	--------------------	--

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending on the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.

PTO/SB/08A (08-03)

Approved for use through 7/31/2005. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known	
				APPLICATION NUMBER	10/735,110
				FILING DATE	12/12/2003
				FIRST NAMED INVENTOR	Nimmakayala et al.
				Group Art Unit	1756
Sheet 2 of 2				Examiner Name	Christopher G. Young
				Attorney Docket Number	P122-65V58

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

	F5	PARK ET AL., Aligning Liquid Crystals Using Replicated Nanopatterns, PSI Scientific Report 2002, Vol VII, p. 85 3/1/2003	
	F6	APPLICATION NO. 11/142,834, naming Inventors Cherala et al., entitled Method of Varying Dimensions of a Substrate during Nano-Scale Manufacturing, filed 6/1/2005	
	F7	APPLICATION NO. 11/142,839, naming Inventors Cherala et al., entitled Apparatus to Vary Dimensions of a Substrate during Nano-Scale Manufacturing, filed 6/1/2005	

Examiner Signature		Date Considered	
-----------------------	--	--------------------	--

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending on the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.